

Notice of References Cited	Application/Control No.	Applicant(s)/Patent Under Reexamination	
	10/677,158	WANG ET AL.	
	Examiner Patricia A. George	Art Unit 1765	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,136,725	10-2000	Loan et al.	438/758
*	C	US-2005/0074983	04-2005	Shinriki et al.	438/785
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf; silicon Processing; Vol. 1, pg 58; para.2 1985; isbn 0-9616721-3-7
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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